

L Number	Hits	Search Text	DB	Time stamp
-	1	"6642092"	USPAT	2004/03/30 11:54
-	1	"6647946"	USPAT	2004/03/30 12:04
-	606	438/151.ccls.	USPAT	2004/03/30 12:04
-	322	438/151.ccls. and TFT	USPAT	2004/03/30 12:04
-	9	438/151.ccls. and TFT and foil	USPAT	2004/03/30 12:05
-	9	438/151.ccls. and TFT and foil and substrate	USPAT	2004/03/30 12:05
-	8	438/151.ccls. and TFT and foil and substrate and electrical	USPAT	2004/03/30 12:17
-	4	438/151.ccls. and TFT and foil and substrate and electrical and isolat\$4	USPAT	2004/03/30 12:17
-	4	438/151.ccls. and TFT and foil and substrate and electrical and isolat\$4 and layer	USPAT	2004/03/30 12:17
-	4	438/151.ccls. and TFT and foil and substrate and electrical and isolat\$4 and layer and drain	USPAT	2004/03/30 12:17
-	4	438/151.ccls. and TFT and foil and substrate and electrical and isolat\$4 and layer and drain and source	USPAT	2004/03/30 12:17
-	4	438/151.ccls. and TFT and foil and substrate and electrical and isolat\$4 and layer and drain and source and channel	USPAT	2004/03/30 12:17
-	3	438/151.ccls. and TFT and foil and substrate and electrical and isolat\$4 and layer and drain and source and channel and polycrystalline	USPAT	2004/03/30 12:18
-	3	438/151.ccls. and TFT and foil and substrate and electrical and isolat\$4 and layer and drain and source and channel and polycrystalline and silicon	USPAT	2004/03/30 12:18
-	3	438/151.ccls. and TFT and foil and substrate and electrical and isolat\$4 and layer and drain and source and channel and polycrystalline and silicon and gate	USPAT	2004/03/30 12:18
-	0	438/151.ccls. and TFT and foil and substrate and electrical and isolat\$4 and layer and drain and source and channel and polycrystalline and silicon and gate and index	USPAT	2004/03/30 12:18
-	0	438/151.ccls. and TFT and foil and substrate and electrical and isolat\$4 and layer and drain and source and channel and polycrystalline and silicon and gate and refract\$4	USPAT	2004/03/30 12:19
-	3	438/151.ccls. and TFT and foil and substrate and electrical and isolat\$4 and layer and drain and source and channel and polycrystalline and silicon and gate and oxide	USPAT	2004/03/31 07:24
-	0	"index of refraction"	USPAT	2004/03/30 12:37
-	0	438/151.ccls. and TFT and foil and substrate and electrical and isolat\$4 and layer and drain and source and channel and polycrystalline and silicon and gate and oxide and refract\$4	USPAT	2004/03/31 07:37
-	56	438/151.ccls. and refract\$4	USPAT	2004/03/31 07:37
-	30	438/151.ccls. and refract\$4 and TFT	USPAT	2004/03/31 07:37
-	2	438/151.ccls. and refract\$4 and TFT and foil	USPAT	2004/03/31 07:37
-	2	438/151.ccls. and refract\$4 and TFT and foil and substrate	USPAT	2004/03/31 07:37

-	1	438/151.ccls. and refract\$4 and TFT and foil and substrate and electrical	USPAT	2004/03/31 07:38
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-	1	438/151.ccls. and refract\$4 and TFT and foil and substrate and electrical and drain	USPAT	2004/03/31 07:38
-	1	438/151.ccls. and refract\$4 and TFT and foil and substrate and electrical and drain and source	USPAT	2004/03/31 07:38
-	1	438/151.ccls. and refract\$4 and TFT and foil and substrate and electrical and drain and source and channel	USPAT	2004/03/31 07:38
-	0	438/151.ccls. and refract\$4 and TFT and foil and substrate and electrical and drain and source and channel and polycrystalline	USPAT	2004/03/31 07:39
-	1	438/151.ccls. and refract\$4 and TFT and foil and substrate and electrical and drain and source and channel and silicon	USPAT	2004/03/31 07:39
-	1	438/151.ccls. and refract\$4 and TFT and foil and substrate and electrical and drain and source and channel and silicon and gate	USPAT	2004/03/31 07:39
-	1	438/151.ccls. and refract\$4 and TFT and foil and substrate and electrical and drain and source and channel and silicon and gate and oxide	USPAT	2004/03/31 07:39

# WEST Search History

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DATE: Thursday, April 01, 2004

Hide?	<u>Set</u> <u>Name</u>	<u>Query</u>	<u>Hit</u> <u>Coun</u>
		<i>DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=OR</i>	
<input type="checkbox"/>	L3	L1 and foil	
<input type="checkbox"/>	L2	L1 and foil	
<input type="checkbox"/>	L1	TFT and (titanium or steel or Kovar) and flex\$4 and (gate with oxide) and (polycrystalline or polysilicon)	3

END OF SEARCH HISTORY